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Day : Monday
 Date: 2/2/2004
 Time: 15:07:13

Inventor Name Search Result

Your Search was:

Last Name = ITO

First Name = NATSUKO

Application#	Patent#	Status	Date Filed	Title	Inventor Name 20
10166303	Not Issued	041	06/11/2002	METHOD OF MANUFACTURING SEMICONDUCTOR DEVICES AND SEMICONDUCTOR MANUFACTURING APPARATUS	ITO, NATSUKO
09971463	Not Issued	041	10/05/2001	PARTICLE-REMOVING APPARATUS FOR A SEMICONDUCTOR DEVICE MANUFACTURING APPARATUS AND METHOD OF REMOVING PARTICLES	ITO, NATSUKO
09962169	Not Issued	061	09/24/2001	SEMICONDUCTOR DEVICE MANUFACTURING APPARATUS AND METHOD FOR MANUFACTURING A SEMICONDUCTOR DEVICE	ITO, NATSUKO
09950759	Not Issued	161	09/13/2001	SEMICONDUCTOR FABRICATION DEVICE AND METHOD FOR PREVENTING THE ATTACHMENT OF EXTRANEIOUS PARTICLES	ITO, NATSUKO
09767960	Not Issued	161	01/24/2001	DUST PARTICLE REMOVING METHOD AND APPARATUS, IMPURITY DETECTING METHOD AND SYSTEM	ITO, NATSUKO
09721703	Not Issued	093	11/27/2000	APPARATUS AND METHOD FOR DETECTING AN END POINT OF A CLEANING PROCESS	ITO, NATSUKO
09685351	6423176	150	10/10/2000	PARTICLE-REMOVING APPARATUS FOR A SEMICONDUCTOR DEVICE MANUFACTURING APPARATUS AND METHOD	ITO, NATSUKO

				OF REMOVING PARTICLES	
<u>09656713</u>	Not Issued	071	09/07/2000	APPARATUS FOR MONITORING PARTICLES AND METHOD OF DOING THE SAME	ITO, NATSUKE
<u>09651186</u>	<u>6346425</u>	150	08/30/2000	VAPOR-PHASE PROCESSING METHOD CAPABLE OF ELIMINATING PARTICLE FORMATION	ITO, NATSUKE
<u>09504435</u>	<u>6284049</u>	150	02/15/2000	PROCESSING APPARATUS FOR FABRICATING LSI DEVICES	ITO, NATSUKE
<u>09443050</u>	Not Issued	164	11/18/1999	PARTICLE DETECTION SYSTEM AND METHOD USING MONITORED OPERATING CONDITIONS OF A PROCESS CHAMBER	ITO, NATSUKE
<u>09413590</u>	<u>6115120</u>	150	10/06/1999	SYSTEM AND METHOD FOR DETECTING PARTICLES PRODUCED IN A PROCESS CHAMBER BY SCATTERING LIGHT	ITO , NATSUKE
<u>09290636</u>	<u>6184489</u>	150	04/12/1999	PARTICLE-REMOVING APPARATUS FOR A SEMICONDUCTOR DEVICE MANUFACTURING APPARATUS AND METHOD OF REMOVING PARTICLES	ITO , NATSUKE
<u>09273293</u>	<u>6306770</u>	150	03/19/1999	METHOD AND APPARATUS FOR PLASMA ETCHING	ITO , NATSUKE
<u>09236593</u>	Not Issued	161	01/26/1999	PHARMACEUTICAL COMPOSITIONS FOR THE TREATMENT OF ISCHEMIC BRAIN DAMAGE	ITOH , NATSUKE
<u>09070750</u>	<u>6042650</u>	150	05/01/1998	PROCESSING APPARATUS FOR FABRICATING LSI WITH PROTECTED BEAM DAMPER	ITO , NATSUKE
<u>08989630</u>	<u>5861951</u>	150	12/12/1997	PARTICLE MONITORING INSTRUMENT	ITO , NATSUKE
<u>08837942</u>	<u>5870189</u>	150	04/28/1997	PARTICLE MONITOR AND PARTICLE-FREE RECESSING SYSTEM WITH PARTICLE MONITOR	ITO , NATSUKE
<u>08541266</u>	<u>5747991</u>	150	10/12/1995	CAPACITANCE TYPE ACCELERATION SENSOR	ITO , NATSUKE
<u>08252656</u>	Not	161	06/01/1994	ACCELERATION SENSOR	ITO , NATSUKE

	Issued				
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	ITO	NATSUKO	

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PALM INTRANET

Day : Monday
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Inventor Name Search Result

Your Search was:

Last Name = UESUGI

First Name = FUMIHIKO

Application#	Patent#	Status	Date Filed	Title	Inventor Name 18
<u>10166303</u>	Not Issued	041	06/11/2002	METHOD OF MANUFACTURING SEMICONDUCTOR DEVICES AND SEMICONDUCTOR MANUFACTURING APPARATUS	UESUGI, FUMIHIKO
<u>09971463</u>	Not Issued	041	10/05/2001	PARTICLE-REMOVING APPARATUS FOR A SEMICONDUCTOR DEVICE MANUFACTURING APPARATUS AND METHOD OF REMOVING PARTICLES	UESUGI, FUMIHIKO
<u>09962169</u>	Not Issued	061	09/24/2001	SEMICONDUCTOR DEVICE MANUFACTURING APPARATUS AND METHOD FOR MANUFACTURING A SEMICONDUCTOR DEVICE	UESUGI, FUMIHIKO
<u>09950759</u>	Not Issued	161	09/13/2001	SEMICONDUCTOR FABRICATION DEVICE AND METHOD FOR PREVENTING THE ATTACHMENT OF EXTRANEIOUS PARTICLES	UESUGI, FUMIHIKO
<u>09767960</u>	Not Issued	161	01/24/2001	DUST PARTICLE REMOVING METHOD AND APPARATUS, IMPURITY DETECTING METHOD AND SYSTEM	UESUGI, FUMIHIKO
<u>09721703</u>	Not Issued	093	11/27/2000	APPARATUS AND METHOD FOR DETECTING AN END POINT OF A CLEANING PROCESS	UESUGI, FUMIHIKO
<u>09685351</u>	<u>6423176</u>	150	10/10/2000	PARTICLE-REMOVING APPARATUS FOR A SEMICONDUCTOR DEVICE MANUFACTURING APPARATUS AND METHOD	UESUGI, FUMIHIKO

				OF REMOVING PARTICLES	
<u>09656713</u>	Not Issued	071	09/07/2000	APPARATUS FOR MONITORING PARTICLES AND METHOD OF DOING THE SAME	UESUGI, FUMIHIKO
<u>09504435</u>	<u>6284049</u>	150	02/15/2000	PROCESSING APPARATUS FOR FABRICATING LSI DEVICES	UESUGI, FUMIHIKO
<u>09443050</u>	Not Issued	164	11/18/1999	PARTICLE DETECTION SYSTEM AND METHOD USING MONITORED OPERATING CONDITIONS OF A PROCESS CHAMBER	UESUGI, FUMIHIKO
<u>09413590</u>	<u>6115120</u>	150	10/06/1999	SYSTEM AND METHOD FOR DETECTING PARTICLES PRODUCED IN A PROCESS CHAMBER BY SCATTERING LIGHT	UESUGI , FUMIHIKO
<u>09290636</u>	<u>6184489</u>	150	04/12/1999	PARTICLE-REMOVING APPARATUS FOR A SEMICONDUCTOR DEVICE MANUFACTURING APPARATUS AND METHOD OF REMOVING PARTICLES	UESUGI , FUMIHIKO
<u>09273293</u>	<u>6306770</u>	150	03/19/1999	METHOD AND APPARATUS FOR PLASMA ETCHING	UESUGI , FUMIHIKO
<u>09070750</u>	<u>6042650</u>	150	05/01/1998	PROCESSING APPARATUS FOR FABRICATING LSI WITH PROTECTED BEAM DAMPER	UESUGI , FUMIHIKO
<u>08989630</u>	<u>5861951</u>	150	12/12/1997	PARTICLE MONITORING INSTRUMENT	UESUGI , FUMIHIKO
<u>08837942</u>	<u>5870189</u>	150	04/28/1997	PARTICLE MONITOR AND PARTICLE-FREE RECESSING SYSTEM WITH PARTICLE MONITOR	UESUGI , FUMIHIKO
<u>07717603</u>	<u>5393577</u>	150	06/19/1991	METHOD FOR FORMING A PATTERNED LAYER BY SELECTIVE CHEMICAL VAPOR DEPOSITION	UESUGI , FUMIHIKO
<u>07123460</u>	<u>4873413</u>	150	11/20/1987	METHOD AND APPARATUS FOR WRITING A LINE ON A PATTERNED SUBSTRATE	UESUGI , FUMIHIKO

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PALM INTRANET

Day : Monday
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Inventor Name Search Result

Your Search was:

Last Name = MORIYA

First Name = TSUYOSHI

Application#	Patent#	Status	Date Filed	Title	Inventor Name 41
<u>10691516</u>	Not Issued	019	10/24/2003	IMAGE FORMATION APPARATUS	MORIYAMA, TSUYOSHI
<u>10610819</u>	Not Issued	020	07/02/2003	AN INSERT SHEET TRANSPORTING APPARATUS AN INSERT SHEET TRANSPORTING METHOD AND AN IMAGE FORMING APPARATUS	MORIYAMA, TSUYOSHI
<u>10463430</u>	Not Issued	030	06/18/2003	SHEET-THICKNESS DETECTOR DEVICE AND SHEET-PROCESSING APPARATUS, IMAGE-FORMING APPARATUS HAVING THE SAME	MORIYAMA, TSUYOSHI
<u>10437734</u>	Not Issued	020	05/14/2003	SHEET CONVEYING APPARATUS	MORIYAMA, TSUYOSHI
<u>10403706</u>	Not Issued	071	03/31/2003	IMAGE FORMING APPARATUS, SHEET PROCESSING APPARATUS, SHEET PROCESSING METHOD, AND BOOK-BINDING METHOD	MORIYAMA, TSUYOSHI
<u>10368316</u>	Not Issued	020	02/14/2003	IMAGE FORMING APPARATUS, SHEET CONTAINING DEVICE, SHEET INSERTING DEVICE, BOOK-BINDING SYSTEM, AND SHEET PROCESSING APPARATUS	MORIYAMA, TSUYOSHI
<u>10314290</u>	Not Issued	071	12/09/2002	IMAGE FORMING APPARATUS WITH PAPER THICKNESS DETECTION UNIT FOR DETECTING OVERLAP OF REGULAR AND INSERTION SHEETS	MORIYAMA, TSUYOSHI

<u>10256194</u>	<u>6636720</u>	150	09/27/2002	IMAGE FORMING APPARATUS, CONTROL METHOD THEREOF, IMAGE FORMING METHOD, AND STORAGE MEDIUM	MORIYAMA, TSUYOSHI
<u>10195427</u>	Not Issued	041	07/16/2002	SHEET POST-PROCESSING APPARATUS HAVING OFFSET MOUNTING MEANS	MORIYAMA, TSUYOSHI
<u>10166303</u>	Not Issued	041	06/11/2002	METHOD OF MANUFACTURING SEMICONDUCTOR DEVICES AND SEMICONDUCTOR MANUFACTURING APPARATUS	MORIYA, TSUYOSHI
<u>10150081</u>	Not Issued	041	05/20/2002	APPARATUS FOR PRODUCING THIN FILMS	MORIYAMA, TSUYOSHI
<u>10011824</u>	<u>6546226</u>	150	11/05/2001	IMAGE FORMING APPARATUS, SHEET PROCESSING APPARATUS, SHEET PROCESSING METHOD, AND BOOK-BINDING METHOD	MORIYAMA, TSUYOSHI
<u>09973840</u>	<u>6603951</u>	150	10/11/2001	IMAGE FORMATION APPARATUS AND IMAGE FORMATION SYSTEM	MORIYAMA, TSUYOSHI
<u>09971463</u>	Not Issued	041	10/05/2001	PARTICLE-REMOVING APPARATUS FOR A SEMICONDUCTOR DEVICE MANUFACTURING APPARATUS AND METHOD OF REMOVING PARTICLES	MORIYA, TSUYOSHI
<u>09962169</u>	Not Issued	061	09/24/2001	SEMICONDUCTOR DEVICE MANUFACTURING APPARATUS AND METHOD FOR MANUFACTURING A SEMICONDUCTOR DEVICE	MORIYA, TSUYOSHI
<u>09950759</u>	Not Issued	161	09/13/2001	SEMICONDUCTOR FABRICATION DEVICE AND METHOD FOR PREVENTING THE ATTACHMENT OF EXTRANEIOUS PARTICLES	MORIYA, TSUYOSHI
<u>09838220</u>	<u>6473590</u>	150	04/20/2001	SHEET POST-PROCESSING APPARATUS HAVING OFFSET MOUNTING MEANS	MORIYAMA, TSUYOSHI
<u>09778993</u>	Not Issued	030	02/07/2001	IMAGE FORMING APPARATUS, METHOD OF CONTROLLING SAME AND	MORIYAMA, TSUYOSHI

				STORAGE MEDIUM THEREFOR	
<u>09772990</u>	<u>6505017</u>	150	01/31/2001	IMAGE FORMING APPARATUS, CONTROL METHOD THEREOF, IMAGE FORMING METHOD, AND STORAGE MEDIUM	MORIYAMA, TSUYOSHI
<u>09767960</u>	Not Issued	161	01/24/2001	DUST PARTICLE REMOVING METHOD AND APPARATUS, IMPURITY DETECTING METHOD AND SYSTEM	MORIYA, TSUYOSHI
<u>09737280</u>	Not Issued	061	12/15/2000	SHEET HANDLING APPARATUS WHICH INSERTS INSERT SHEETS BETWEEN RECORDING SHEETS HAVING IMAGE FORMED THEREON, METHOD OF CONTROLLING SAME, IMAGE FORMING APPARATUS AND STORAGE MEDIUM THEREFOR	MORIYAMA, TSUYOSHI
<u>09721703</u>	Not Issued	093	11/27/2000	APPARATUS AND METHOD FOR DETECTING AN END POINT OF A CLEANING PROCESS	MORIYA, TSUYOSHI
<u>09685351</u>	<u>6423176</u>	150	10/10/2000	PARTICLE-REMOVING APPARATUS FOR A SEMICONDUCTOR DEVICE MANUFACTURING APPARATUS AND METHOD OF REMOVING PARTICLES	MORIYA, TSUYOSHI
<u>09671030</u>	<u>6348417</u>	150	09/27/2000	SEMICONDUCTOR DEVICE MANUFACTURING APPARATUS AND SEMICONDUCTOR DEVICE MANUFACTURING METHOD	MORIYAMA, TSUYOSHI
<u>09656713</u>	Not Issued	071	09/07/2000	APPARATUS FOR MONITORING PARTICLES AND METHOD OF DOING THE SAME	MORIYA, TSUYOSHI
<u>09651186</u>	<u>6346425</u>	150	08/30/2000	VAPOR-PHASE PROCESSING METHOD CAPABLE OF ELIMINATING PARTICLE FORMATION	MORIYA, TSUYOSHI
<u>09494303</u>	<u>6330422</u>	150	01/31/2000	IMAGE FORMATION APPARATUS AND IMAGE	MORIYAMA, TSUYOSHI

				FORMATION SYSTEM	
<u>09488100</u>	<u>6351625</u>	150	01/18/2000	IMAGE FORMING APPARATUS, SHEET PROCESSING APPARATUS, SHEET PROCESSING METHOD, AND BOOK-BINDING METHOD	MORIYAMA, TSUYOSHI
<u>09452373</u>	<u>6371472</u>	150	12/01/1999	SHEET PROCESSING FOR STACKING SHIFTED SHEET BUNDLES	MORIYAMA, TSUYOSHI
<u>09443050</u>	Not Issued	164	11/18/1999	PARTICLE DETECTION SYSTEM AND METHOD USING MONITORED OPERATING CONDITIONS OF A PROCESS CHAMBER	MORIYA, TSUYOSHI
<u>09438527</u>	<u>6386080</u>	150	11/12/1999	SHEET PROCESSOR THAT ADJUSTS A PUNCHING OPERATION POSITION BASED ON A DETECTED SHEET EDGE AND ASSOCIATED IMAGE FORMING APPARATUS	MORIYAMA, TSUYOSHI
<u>09438525</u>	<u>6219503</u>	150	11/12/1999	SHEET PROCESSING APPARATUS AND METHOD WITH MULTI-MODE SHEET CONVEYING	MORIYAMA, TSUYOSHI
<u>09418590</u>	<u>6263173</u>	150	10/15/1999	IMAGE FORMATION APPARATUS HAVING SELECTION OF DIFFERENT IMAGE TYPES FOR IMAGE FORMATION	MORIYAMA, TSUYOSHI
<u>09413590</u>	<u>6115120</u>	150	10/06/1999	SYSTEM AND METHOD FOR DETECTING PARTICLES PRODUCED IN A PROCESS CHAMBER BY SCATTERING LIGHT	MORIYA, TSUYOSHI
<u>09290636</u>	<u>6184489</u>	150	04/12/1999	PARTICLE-REMOVING APPARATUS FOR A SEMICONDUCTOR DEVICE MANUFACTURING APPARATUS AND METHOD OF REMOVING PARTICLES	MORIYA, TSUYOSHI
<u>09282489</u>	<u>6391116</u>	150	03/31/1999	SEMICONDUCTOR DEVICE MANUFACTURING APPARATUS AND SEMICONDUCTOR DEVICE MANUFACTURING METHOD	MORIYAMA, TSUYOSHI

<u>09273293</u>	<u>6306770</u>	150	03/19/1999	METHOD AND APPARATUS FOR PLASMA ETCHING	MORIYA , TSUYOSHI
<u>09261955</u>	<u>6337970</u>	150	03/03/1999	IMAGE FORMING APPARATUS HAVING SHEET PROCESSOR	MORIYAMA , TSUYOSHI
<u>09092091</u>	<u>6413884</u>	150	06/05/1998	METHOD OF PRODUCING THIN FILMS USING CURRENT OF PROCESS GAS AND INERT GAS COLLIDING WITH EACH OTHER	MORIYAMA , TSUYOSHI
<u>08843271</u>	<u>6094510</u>	150	04/14/1997	IMAGE PROCESSING APPARATUS AND METHOD FOR PREDICTING A COMPRESSION RATE OF IMAGE DATA PROCESSED TO MODIFY AN IMAGE	MORIYAMA , TSUYOSHI
<u>08680863</u>	<u>5889596</u>	150	07/16/1996	CONTROLLING A READING UNIT OF AN IMAGE PROCESSING APPARATUS	MORIYAMA , TSUYOSHI

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